

S/N 09/111,978

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|---|-----------------|-------------|
| Applicant: | Leonard H. Bieman | Examiner: | Hoa Q. Pham |
| Serial No.: | 09/111,978 | Group Art Unit: | 2877 |
| Filed: | July 8, 1998 | Docket: | 139.045USR |
| Title: | SCANNING PHASE MEASURING METHOD AND SYSTEM FOR AN OBJECT AT A VISION STATION | | |

PETITION FOR A ONE-MONTH EXTENSION OF TIME

Assistant Commissioner for Patents
Washington, D.C. 20231

In accordance with the provisions of 37 C.F.R. § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Office Action mailed September 16, 1999, said period of response being extended from December 16, 1999 to January 16, 2000 (Sunday), with the actual date due being January 18, 2000 (the day following a federal holiday).

Please charge the extension fee of \$55.00 and any additional fees or credit overpayment to Deposit Account No. 19-0743.

Respectfully submitted,

LEONARD H. BIEMAN

By his Representatives,

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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
(612) 373-6949

Date

18 January 2000

By

Charles A. Lemaire

Charles A. Lemaire
Reg. No. 36,198

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this 18th day of January, 2000 (Tuesday following a federal holiday).

Charles A. Lemaire
Name

Charles A. Lemaire
Signature